



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiko TSUJI et al.

Group Art Unit: 2881

Application No.: 10/585,001

Examiner: A. SMYTH

Filed: June 29, 2006

Docket No.: 128591

For: AN EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 26, 2011 Restriction Requirement, the period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.